ISC meeting

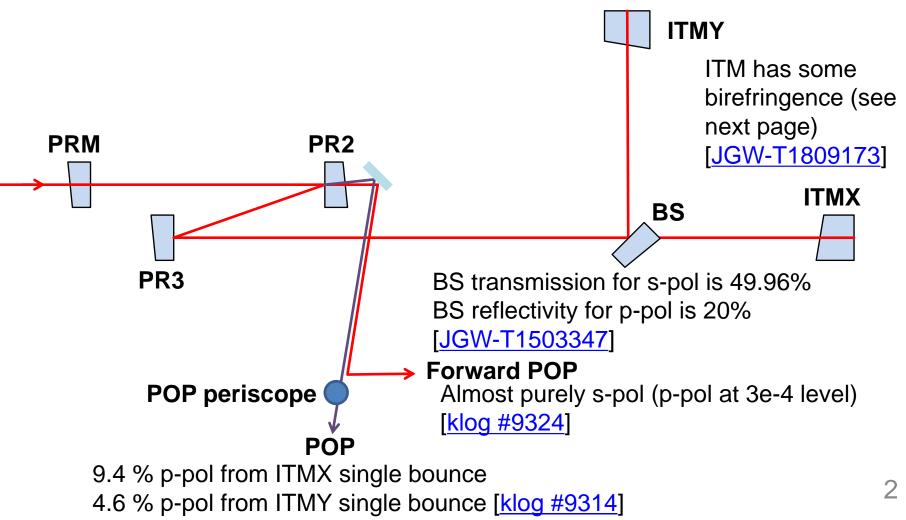
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Polarization issue in PRC

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The Situation

 ITM reflection has some p-pol, while forward beam is almost purely s-pol



ITM Birefringence

 Vendor measured transmission wavefront error (TWE) with circular polarization, but TWE measured with s-pol was different

	specification	vendor report	measured
ITMX	< 6nm	3.47	25.9nm
ITMY	< 6nm	4.07	30.1nm

Table 6. figure error of TWE at 140mm aperture

- This suggests that ITM has some birefringence
- Optical path length difference between two polarizations $\Delta l_{\rm b}$ gives phase difference of $lpha=2\pi\Delta l_{\rm b}/\lambda$

ITM Birefringence

- If we treat RMS linearly, $\Delta l_{\rm b}$ can be written as $\Delta l_{\rm b} = l_{\rm o} - l_{\rm e'} = 2l_{\rm u} - 2l_{\rm e'}$ where $l_{\rm u/o/e'}$ are the optical path length measured with circular polarization (~5 nm RMS by vendor) and
 - polarization aligned with o/e' axes (~30 nm RMS by Caltech)
- Maximum power loss due to s-pol turning into p-pol is $\rho=(1-\cos 2\alpha)/2\simeq \alpha^2$ (2 for round-trip in ITM)
- The power loss will be 7.0% for X and 9.5% for Y
- This corresponds to the power ratio at POP (p/(s+p)) of 9.6 % for X and 5.8 % for Y (note that BS reflectivity is different between polarizations)
- This seems to (amazingly) agree with the measurement (9.4% for X and 4.8% for Y)

Implications

- We need both uniform $l_{\rm s}$ and small $\Delta l_{\rm b}$ but this cannot be achieved by surface corrections
- Using ordinary and extraordinary refractive indices, $\Delta l_{\rm b}$ can be written as $\Delta l_{\rm b} = dn_o(n_o^2 - n_e^2)\theta^2/(2n_e^2)$ For sapphire @ 1064 nm $n_e = 1.747$ where θ is angle between c-axis and beam axis, JGW-T0400030 and d is ITM thickness (15cm) Note that they are different in cryogenic temperatures and there might be additional birefringence due to stress or something
- If we require loss to be smaller than a threshold,

$$\begin{aligned} \Delta l_{\rm b} &< \sqrt{\lambda^2 \rho_{\rm th}/(2\pi)^2} \\ \theta &< \sqrt{\frac{2n_e^2 \sqrt{\lambda^2 \rho_{\rm th}/(2\pi)^2}}{dn_o(n_o^2 - n_e^2)}} \end{aligned}$$

For 10% (1000ppm) loss, these will be 54 nm (5.4 nm) and 0.41 deg (0.13 deg) 5

Other Possibilities

 The shape of p-pol beams from ITMX and ITMY seems similar which implies common p-pol generation? [klog #9329] Common stress due to suspension?

- Beam height changes could create p-pol beam? (we have 1/300 inclination)
- Beam clipping creates p-pol beam somehow?
- Birefringence in ITM coating? (might be able to check by measuring the amount of p-pol at room temperature) 6

Sapphire Axes

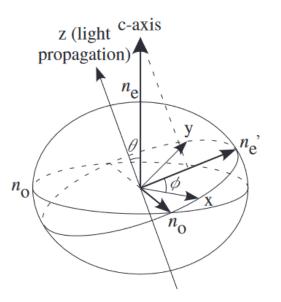
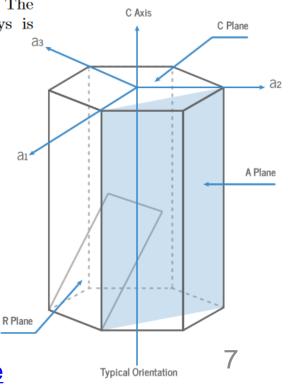


Figure 1. If the c-axis of the sapphire sample inclines by an angle θ from the z-axis, the phase speed of light propagating along the zaxis depends on the direction of its electric field vector **E**. The phase speed of a beam whose electric field is parallel to the projection of the c-axis onto the xy-plane, which inclines by an angle ϕ from the x-axis, is $c/n'_{\rm e}$ and the phase speed of a beam whose electric field is perpendicular to the direction is $c/n_{\rm o}$. The phase retardation between these two rays is given by Eq. 2.

Tokunari+, JPCS 32, 432 (2006)



http://jp.rubicontechnology.com/company/sapphire

Calculation Details

- Phase difference between o-axis and e'-axis $lpha=2\pi d(n_o-n_{e'})/\lambda$
- p-pol power after ITM reflection $P_p/P_{in} = (1 - \cos^2 2\phi)(1 - \cos 2\alpha)/2$ $\leq (1 - \cos 2\alpha)/2$ $\approx \alpha^2$ s-pol power depends on a Maximum s-pol power: Pin Minimum s-pol power:
- Transmission wavefront error $d(n_o - n_{e'}) = 2(\underline{d(n_o + n_{e'})/2} - \underline{dn_{e'}})$

Measured with circular polarization, and this is minimized by polishing

Not directly measured. RMS measured with s-pol shows small dependence on mirror orientation, and this suggests $dn_{e'}$ map is similar to dn_{o} map in RMS

 $\theta < 0.2 \text{ deg } (\underline{\text{JGW-T1809173}})$ But ϕ is totally unknown

Φ

polarization

plane

n

s-pol

n